

Appl. No. 10/724,570

Amdt. Dated May 25, 2007

Reply to Final Office Action of April 27, 2007

Attorney Docket No. 81788.0263

Customer No.: 26021



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Akira Tanaka

Serial No: 10/724,570

Confirmation No.: 8635

Filed: November 26, 2003

For: SEMICONDUCTOR LASER
ELEMENT, METHOD OF
FABRICATION THEREOF, AND
MULTI-WAVELENGTH
MONOLITHIC SEMICONDUCTOR
LASER DEVICE

Art Unit: 2828

Examiner: Tod Thomas Van
Roy

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AMENDMENT

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This is in response to the Final Office Action dated April 27, 2007. Please
amend the above-referenced application as follows:

The claims are listed beginning on page 2 of this paper.

Remarks begin on page 5 of this paper.

Entered
TK
06/11/02
TK